

<b>Notice of References Cited</b>	Application/Control No. 10/062,669	Applicant(s)/Patent Under Reexamination SEBIRE, BENOIST	
	Examiner Mark A. Mais	Art Unit 2664	Page 1 of 1

**U.S. PATENT DOCUMENTS**

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*	B	US-2004/0233899	11-2004	Vayanos et al.	370/352
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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